

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Kauko JANKA *et al.*

Appln. No. 10/518,006

Confirmation No. 6705

Filed: December 14, 2004

For: **METHOD FOR THE PREPARATION OF
DOPED OXIDE MATERIAL**

Art Unit: 1791

Examiner: John M. Hoffman

Atty. Docket No. 43289-211640

Customer No.
26694
PATENT TRADEMARK OFFICE

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA. 22313-1450

Madam:

Applicants direct the attention of the U.S. Patent and Trademark Office to the references listed on the attached PTO/SB/08, respectfully request that the references be considered during the prosecution of this application, be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This is Information Disclosure Statement is being submitted after issuance of a non-final office action but before issuance of a final office action or notice of allowance. Each item of information contained in the information disclosure statement as first cited in the attached office action issued June 9, 2009, by the Japanese patent office in a counterpart application.

The undersigned authorizes the Director to charge any required fee or deficiency to Deposit Account No. 22-0261, under Order No. 43289-211640.

Respectfully submitted,

Date: July 8, 2009

/Eric J. Franklin/

Eric J. Franklin, Registration No. 37,134
VENABLE, LLP
P.O. Box 34385
Washington, D.C. 20043-9998
Telephone: (202) 344-4000
Telefax : (202) 344-8300